

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP AMENDMENT
)	
Jung-hyun Lee et al.)	Group Art Unit: 2811
)	
Application No.: 10/797,046)	Examiner: Ori NADAV
)	
Filed: March 11, 2004)	Confirmation No.: 4688
)	
For: METHOD FOR MANUFACTURING)	
OXIDE FILM HAVING HIGH)	
DIELECTRIC CONSTANT,)	
CAPACITOR HAVING DIELECTRIC)	
FILM FORMED USING THE)	
METHOD, AND METHOD FOR)	
MANUFACTURING THE SAME)	

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In complete response to the Official Action dated February 15, 2008,
Applicants submit herewith a petition for two-month extension of time extending the
period of response from May 15, 2008 to July 15, 2008, and the following Remarks.

Remarks begin on page 2 of this Response.